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STATEMENT BY APPLICANT**

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Complete if Known

Application Number	10/824,678
Filing Date	April 15, 2004
First Named Inventor	RUECKES et al.
Art Unit	2812
Examiner Name	TBA
Attorney Docket Number	112010.152US2 NAN-28

Sheet	1	of	5
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U. S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
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Examiner Signature		Date Considered	8/14/05
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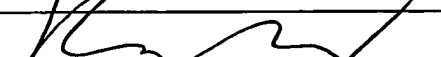
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			Art Unit	2812	
			Examiner Name	TBA	
Sheet	2	of	5	Attorney Docket Number	112010.152US2 NAN-28

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		Number-Kind Code ^{2(i) known}			
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Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, volume- issue number(s), page(s), publisher, city and/or country where published.	T ²
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)			Application Number	10/824,678	
			Filing Date	April 15, 2004	
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			Art Unit	2812	
			Examiner Name	TBA	
Sheet	4	of	5	Attorney Docket Number	112010.152US2 NAN-28

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Sheet	5	of	5	Attorney Docket Number	112010.152US2 NAN-28

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